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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 4127

SERIAL NUMBER 09/785,815	FILING DATE 02/16/2001 RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 4969/USA/ISM/COPPER/SB
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APPLICANTS

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** CONTINUING DATA *****

This appln claims benefit of 60/237,908 10/04/2000
and is a CIP of 09/350,210 07/09/1999 PAT 6,267,853
and is a CIP of 09/350,212 07/09/1999 PAT 6,516,815
and is a CIP of 09/614,406 07/12/2000 PAT 6,494,219

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/09/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature 	Initials sn		

ADDRESS

32588
APPLIED MATERIALS, INC.
2881 SCOTT BLVD. M/S 2061
SANTA CLARA, CA
95050

TITLE

Integrated semiconductor substrate bevel cleaning apparatus and method

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)

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b b f